A Chirp-Compensation Technique Using Incident-Angle Changes of Cavity Mirrors in a Femtosecond Pulse Laser

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Abstract—A technique for chirp-compensation in a CPM laser is presented. By using the change of the incident angle to multilayer dielectric cavity mirrors, the intracavity second-order dispersion $\delta(\omega)$ is adjusted without any additional elements. It is confirmed that the optimum value of $\delta(\omega)$ is adjusted without any additional elements. It is confirmed that the thing for femtosecond pulse generation is to compensate the effect of the third-order dispersion, there are presently four techniques as follows: 1) the down-chirp compensation by the adjustment of the optical path in a prism inserted in the cavity [1], 2) the up-chirp compensation by the adjustment of the distance between four prisms inserted in the cavity [2], 3) the up-chirp compensation by the adjustment of the incident angle to a pair of Gires–Tournois interferometers used as parts of cavity mirrors [3], and 4) the up-chirp compensation by the use of the optimum second-order dispersion (the details will be described below) due to $\lambda_0/4$ multilayer dielectric mirrors composing of the cavity [4]. The former three techniques necessitate the additional optical elements which furthermore complicate the optical alignment of the CPM ring laser. On the other hand, the last one has the inconvenience that cavity mirrors must be exchanged to other mirrors of different coatings to determine the optimum dispersion. In this paper we report that, by the change of the incident angle to cavity mirrors instead of the exchange of mirrors in the last technique, up-chirp can be compensated. In addition, it is shown that the amount of the second-order dispersion obtained for the up-chirp compensation agrees well with a recent analytic result of chirp behaviors due to intracavity self-phase modulation [5]. Furthermore, the influence of the third-order dispersion due to mirrors at the optimum amount of the second-order dispersion on femtosecond pulses is estimated.

The simple CPM ($R6G + DODCI$) laser used without additional elements is nearly identical to the one we previously described [4], except for the following points. The intracavity second-order dispersion was varied by moving mirrors $M_6$ and $M_7$ to the opposite direction of each other, as shown by arrow bars in Fig. 1(a). That is, the incident angles to mirrors $M_6$ and $M_7$, respectively, were varied from 45 to 60° and from 40 to 25°. The details of the mirror coatings will be described below. The transmission of the output coupling mirrors ($M_6$ or $M_7$) is about 0.5 ~ 1.0 percent around 630 nm. Pump powers of 2.4~3.2 W at 514.5 nm were provided by a CW Ar ion laser. The DODCI concentration was $5 \times 10^{-3}$ M/l in a jet from a 39 μm wide nozzle slit. Typical average output power was 10 mW. The femtosecond pulse durations were measured by a background-free SHG autocorrelator (0.2 mm KDP crystal) operated in a fast-scan mode and a slow-scan mode. Hyperbolic secant-squared pulse shapes were assumed throughout in driving the pulse durations from the full width at half maximum of the intensity autocorrelation functions. The pulse spectra around 625~640 nm were monitored on an oscilloscope using an optical multichannel analyzer.

The phase of the EM wave of the laser pulse is shifted when the wave is reflected by a $\lambda_0/4$ multilayer dielectric mirror. The phase shift $\phi(\omega)$ is a function of the optical angular frequency $\omega$ and can be calculated using a matrix formulation [6]. The effective phase-dispersion for chirp compensation is the second-order angular-frequency derivative $\phi'(\omega)$ of the phase shift (the second-order dispersion). The quantity $\phi(\omega)$ is related to the group-velocity dispersion $\tilde{\kappa}(\omega)$ of a dispersive material with a length $l$ by an equation $\phi(\omega) = -il\tilde{\kappa}(\omega)$ ($\kappa(\omega)$: wavenumber). Therefore, the positive second-order dispersion $\phi(\omega)$ corresponds to the negative group-velocity dispersion $\tilde{\kappa}(\omega)$. The value of $\phi(\omega)$ for the reflected laser pulse with a given angular frequency depends on the incident angle $\theta$ to a mirror and the resonance wavelength $\lambda_0$ of the multilayer stack of its mirror.

When the incident angle $\theta$ is larger than 45° and the wavelength $\lambda_d$ of the incident laser-pulse is relatively longer than $\lambda_0$, the $\phi(\omega)$ has a large value $(10^{-20}~10^{-27})$.
The effect on the pulse of the incident angle $\theta$ to cavity mirrors was experimentally examined by the simultaneous movement of mirrors $M_6$ and $M_7$, along the directions of the angle from 45° to 60° and from 40° to 25°, [along arrow bars in Fig. 1(a), respectively. At each 8 mm movement on translation stages, an optimum operating condition such as the pumping power and the alignment of the optical components was carefully adjusted, while monitoring the fast scanned autocorrelation traces on an oscilloscope. Consequently, the pulse duration dependence on the second-order dispersion $\phi(\omega)$ due to all cavity mirrors was obtained as shown in Fig. 2. As the value of $\phi(\omega)$ increases from $0.8 \times 10^{-28}$ to $2.1 \times 10^{-28} \text{s}^2$, the pulse duration decreases from 90 to 55 fs, and then the further increase of $\phi(\omega)$ to $2.5 \times 10^{-28} \text{s}^2$ broadens the pulse duration to 68 fs. The obtained dependence and the value of $\phi(\omega)$ where the shortest pulses were generated, are in agreement with those in the previous experiment based on mirror exchange [4]. This indicates that the negative group-velocity dispersion corresponding to the above value of $\phi(\omega)$ can compensate for up-chirp mainly due to the effect of the nonlinear refractive index of the solvent of the DODCI absorber, ethylene glycol. We shall now below that the amount of this optimum dispersion is reasonable.

Miranda et al. carried out a simplified analysis of frequency-chirp $C(t) = \frac{\delta \phi(t)}{\delta t}$ imposed on femtosecond pulses interacting with a saturable absorber including the effect of nonlinear refractive index due to the solvent [5]. Their results showed that the chirp in a CPM laser remarkably depends on the intracavity pulse energy $E_p$. In the region of $E_p \leq 1 \text{nJ}$, down-chirp due to the transient saturation of the absorption is dominant around the pulse peak, while in the region of $E_p \geq 10 \text{nJ}$, up-chirp due to the time-dependent refractive index of the solvent is dominant. In the present CPM laser, $E_p$ is estimated to be $\sim 15 \text{nJ}$, and, hence, up-chirp $C(0) > 0$ at the pulse peak occurs. By using their numerical result for $C(0)$, which was obtained as a function of the pulse duration with a parameter $E_p$, $C(0)$ for the present CPM laser is estimated to be $\sim 10^{-26} \text{ rad} \cdot \text{s}^{-2}$. Therefore, the amount of the second-order dispersion $\phi(\omega)$ necessary for this up-chirp compensation can be evaluated to be $\sim 10^{-28} \text{s}^2$ at the pulse duration of $T_{\text{in}} = 55 \text{ fs}$ using an equation $\phi(\omega) = C(0)^{-1} / [1 + 8 \times (\ln 2)^2 / (C(0) T_{\text{in}}^2)]$ [7]. This agrees, in order of magnitude, with the experimental value.

Finally, we estimate the effect of the third-order angular-frequency derivative $\phi'(\omega)$ of the phase shift (the third-order dispersion) due to mirrors on femtosecond pulses in the present CPM laser. The value of $\phi'(\omega)$ due to all mirrors at the above obtained optimum value of $\phi(\omega)$ for up-chirp compensation is calculated to be $\sim 1 \times 10^{-4} \text{s}^2$. A few research groups derived an equation describing pulse broadening due to the third-order dispersion [8], [9]. Their results showed that for the input chirp-compensated pulse, the behavior of its output pulse shape is symmetric in respect to the sign of $\phi'(\omega)$. As the value

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of $\hat{\phi}(\omega)$ becomes large, the peak intensity of the main pulse decreases and some small pulses follow after the main pulse. From the application of their analysis to femtosecond pulses, it is found that when chirp-compensated 50 fs pulses are reflected by mirrors of $\hat{\phi}(\omega) = 2 \times 10^{-41}$ s$^3$, they are hardly broadened. However, when 30 fs pulses are reflected by the same mirrors, they are broadened by about two times, and when being reflected by mirrors with less than $\hat{\phi}(\omega) = 4 \times 10^{-42}$ s$^3$ they are hardly broadened. Therefore, for generation of pulses shorter than 50 fs, mirrors having $\hat{\phi}(\omega) \leq 4 \times 10^{-42}$ s$^3$ should be used.

In conclusion, it has been demonstrated as a technique of chirp-compensation in a CPM laser that the change of the incident angle to cavity mirrors has enabled us to adjust the intracavity second-order dispersion and, hence, to compensate for up-chirp and generate pulses as short as 55 fs. In addition, the evaluation on the effect of the third-order dispersion due to mirrors at the optimum second-order dispersion has been done.

REFERENCES


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